



US007400088B2

(12) **United States Patent**
Ryu

(10) **Patent No.:** **US 7,400,088 B2**
(45) **Date of Patent:** **Jul. 15, 2008**

(54) **ORGANIC ELECTROLUMINESCENT
DISPLAY DEVICE**

(75) Inventor: **Seoung-Yoon Ryu**, Yongin-si (KR)

(73) Assignee: **Samsung SDI Co., Ltd.**, Suwon (KR)

(*) Notice: Subject to any disclaimer, the term of this
patent is extended or adjusted under 35
U.S.C. 154(b) by 247 days.

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(21) Appl. No.: **11/185,850**

(22) Filed: **Jul. 21, 2005**

(65) **Prior Publication Data**

US 2006/0017377 A1 Jan. 26, 2006

(30) **Foreign Application Priority Data**

Jul. 22, 2004 (KR) 10-2004-0057383

(51) **Int. Cl.**
H05B 33/00 (2006.01)

(52) **U.S. Cl.** **313/504**; 313/506

(58) **Field of Classification Search** 313/504,
313/506

See application file for complete search history.

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Primary Examiner—Ashok Patel

(74) *Attorney, Agent, or Firm*—H.C. Park & Associates, PLC

(57) **ABSTRACT**

The present invention discloses organic electroluminescent display device and a method for fabricating the same, which includes: a first hole transporting layer formed in the first, second, and third pixel regions; a second hole transporting layer formed on a portion of the first hole transporting layer in the second and third pixel regions; a third hole transporting layer formed on a portion of the second hole transporting layer in the third pixel region. Light emitting layers are formed on each of the first, second, and third hole transporting layers. The thickness of the second hole transporting layer is approximately one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the first and second pixel regions, and the thickness of the third hole transporting layer is approximately one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the second and third pixel regions.

18 Claims, 4 Drawing Sheets

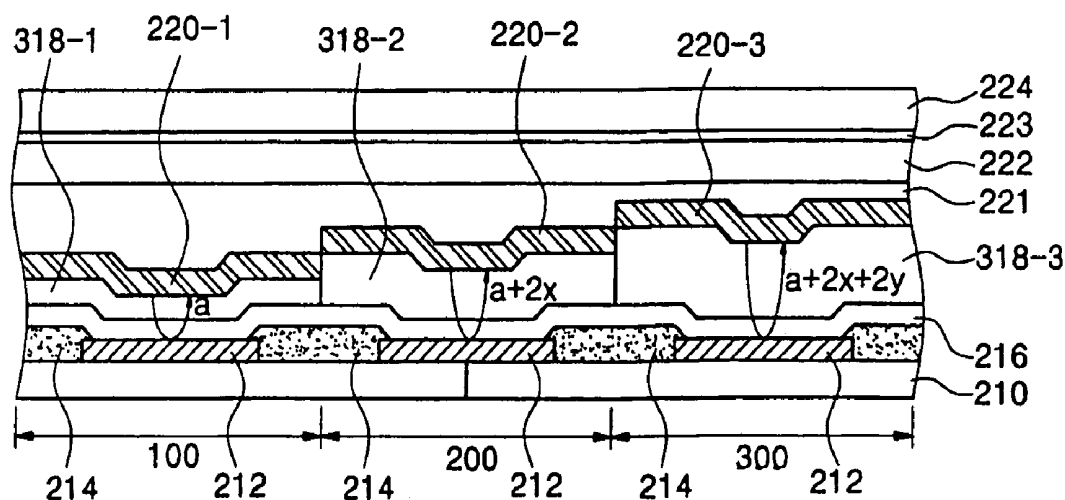


FIG. 1
(PRIOR ART)

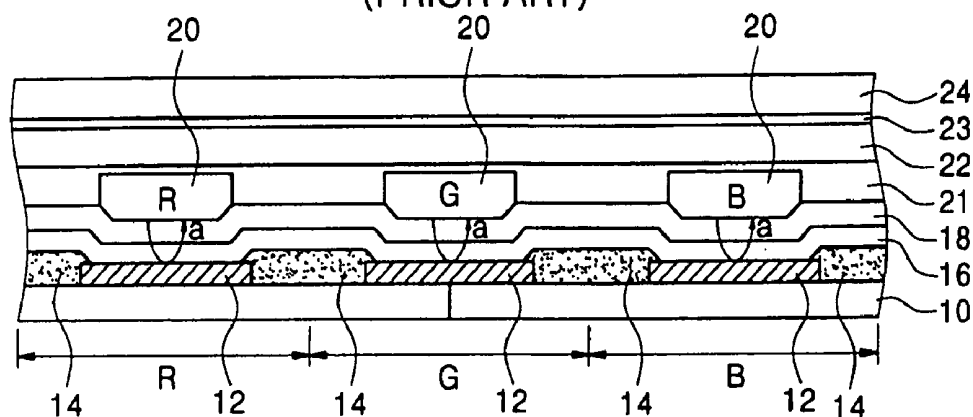


FIG. 2

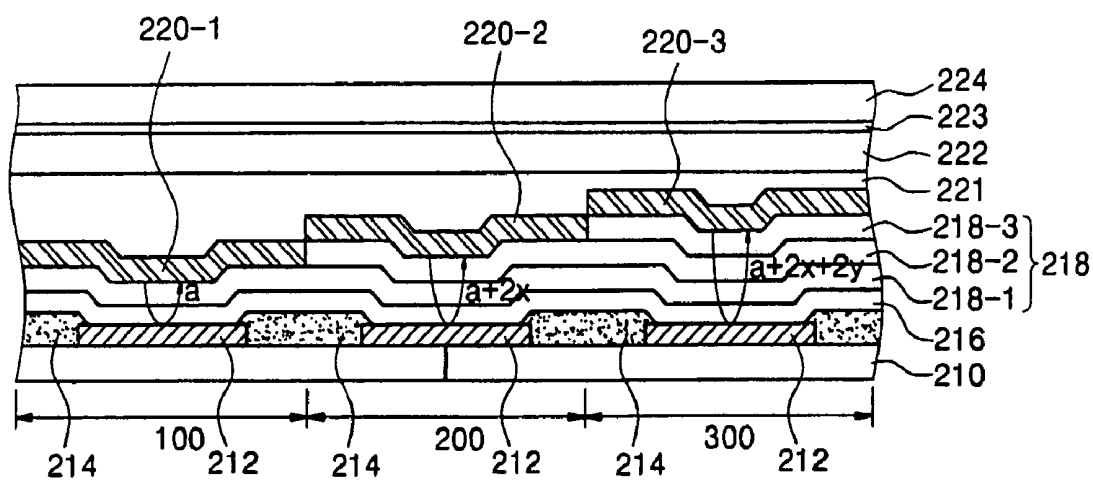


FIG. 3

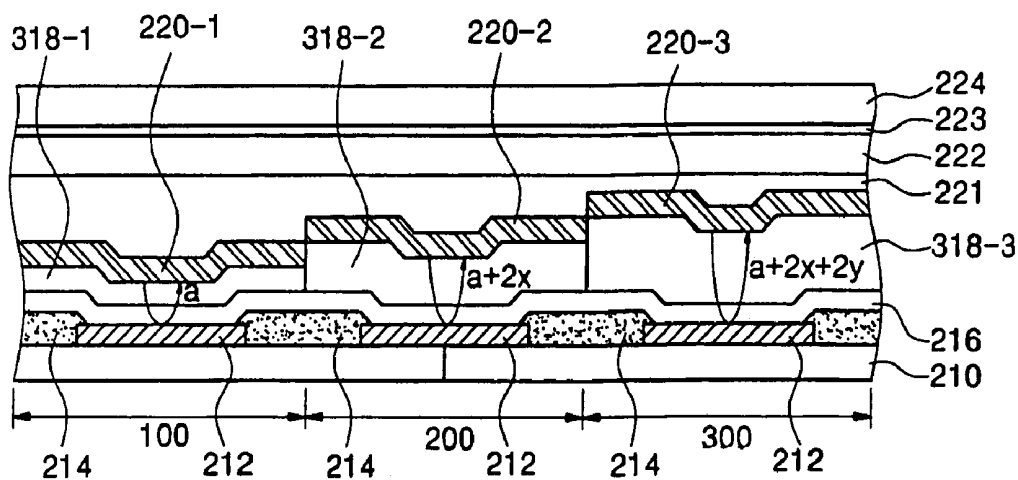


FIG. 4

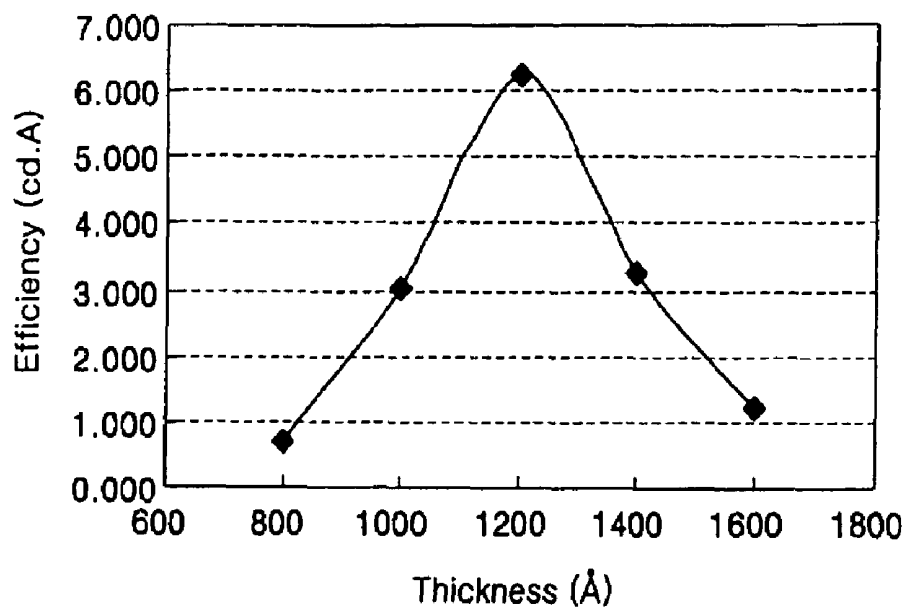


FIG. 5

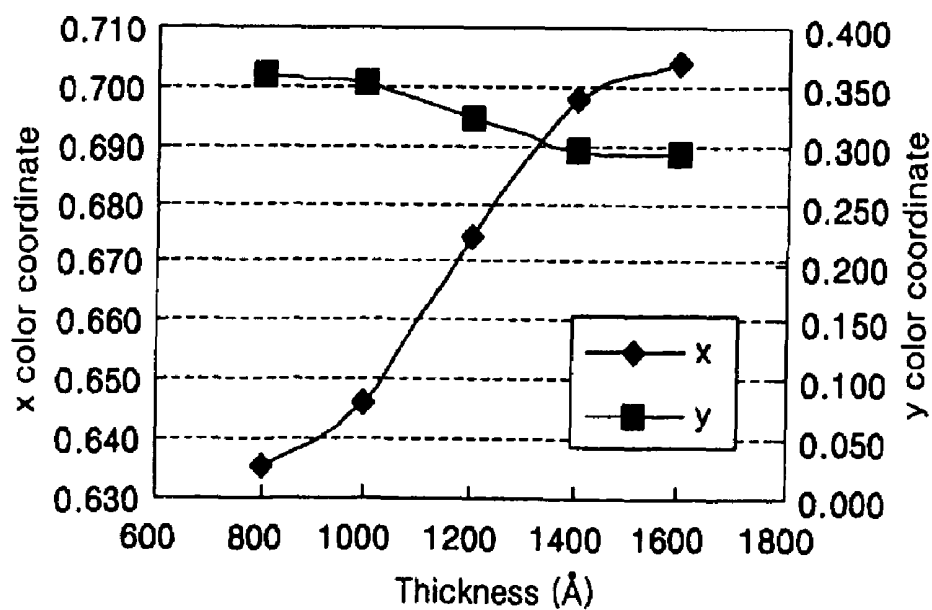


FIG. 6

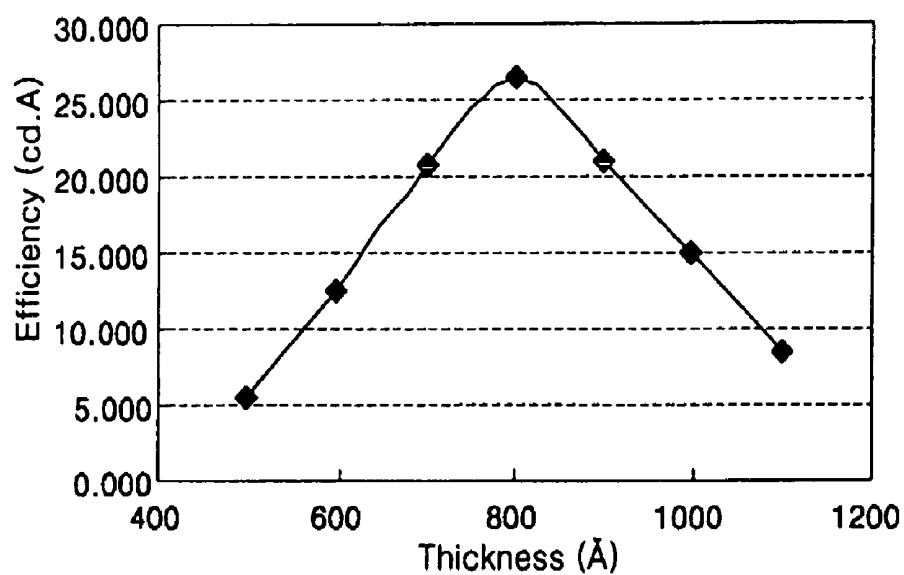


FIG. 7

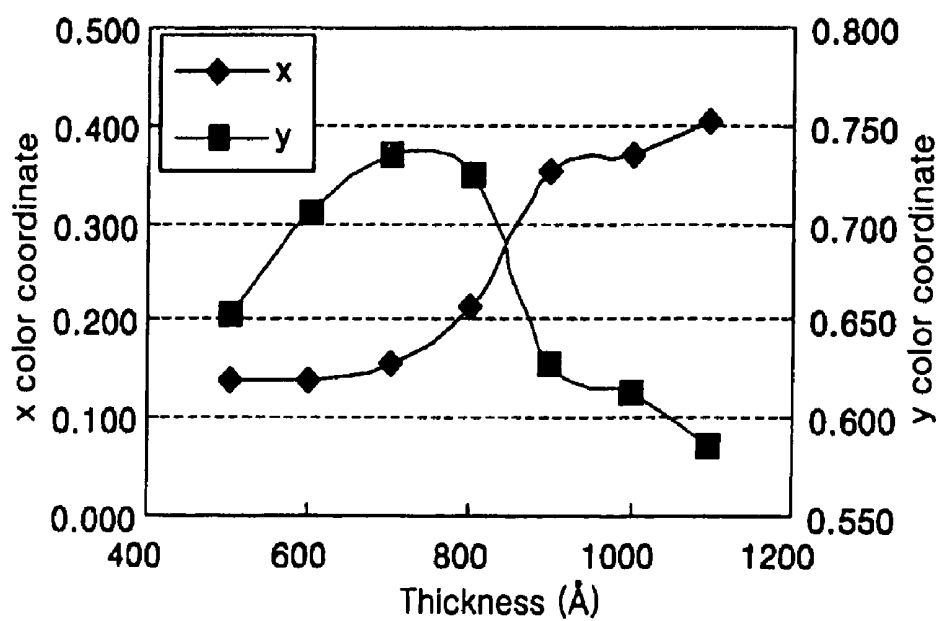
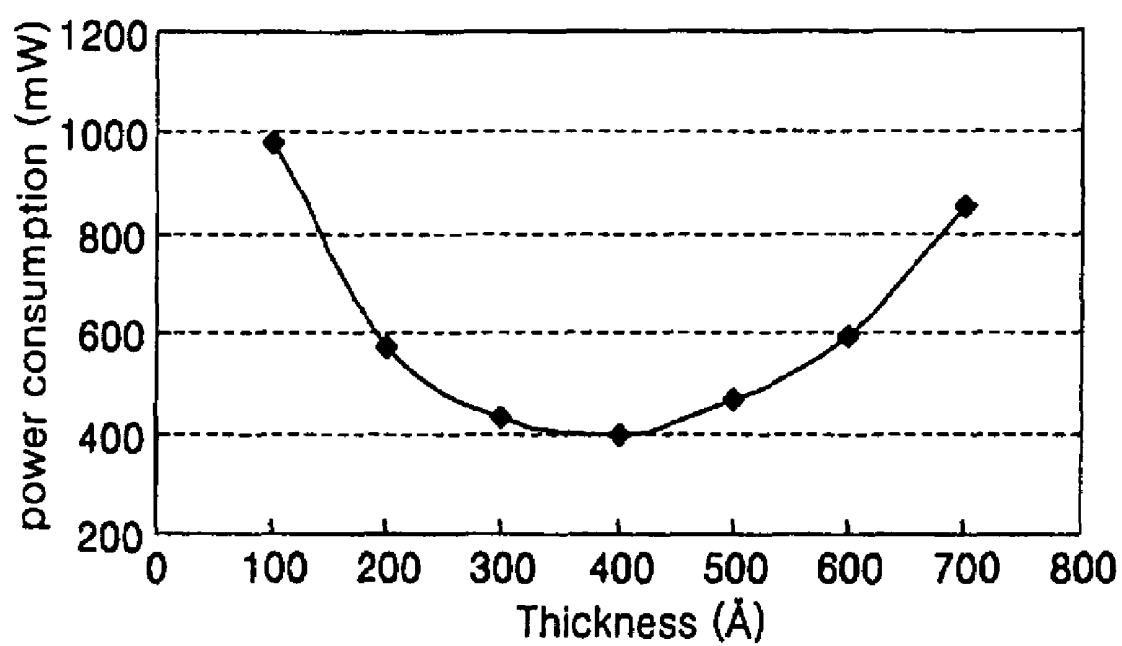


FIG. 8



ORGANIC ELECTROLUMINESCENT DISPLAY DEVICE

CROSS-REFERENCE TO RELATED APPLICATION

This application claims the benefit of Korean Patent Application No. 2004-57383, filed on Jul. 22, 2004, the disclosure of which is hereby incorporated in its entirety by reference herein.

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present invention relates to an organic electroluminescent display device and a method of fabricating the same and, more particularly, to an organic electroluminescent display device having an optimum resonance structure.

2. Description of the Related Art

An organic electroluminescent display ("OLED") device having a thin film transistor ("TFT") is a self light-emissive type display device, which is attracting public attention as a next generation display device because of its wide viewing angle, excellent contrast ratio, and fast response speed.

The OLED device is classified as either an inorganic electroluminescent (EL) device or an organic EL device depending on the material used to form a light emitting layer. Compared to the inorganic EL device, the organic EL device may provide improved display performance in such characteristics as luminance, driving voltage, response speed, and can also provide a full-color display.

The OLED device has a full color feature because it may include a pixel comprising pixel regions defined by the intersection of a plurality of scan lines and a plurality of data lines, which can be arranged substantially perpendicular to each other. Each pixel region corresponds to either red, green, or blue colors.

Referring to FIG. 1, a typical full-color OLED device has a substrate 10 having a red pixel region (R), a green pixel region (G) and a blue pixel region (B); and a plurality of first electrodes 12 formed on portions of substrate 10 overlapping the red pixel region, the green pixel region and the blue pixel region. In the case of a top-emission type OLED device, the first electrode 12 can be a metal electrode, which may be either a reflecting electrode or a transparent electrode containing a reflecting layer.

In order to insulate the pixel regions and to define the pixel, an insulating material layer is deposited and patterned to form a pixel defining layer 14.

A hole injecting layer 16 and a hole transporting layer 18 are formed over the whole surface of substrate 10 to cover the first electrodes 12 as a common layer.

A light emitting material layer is deposited on portions of hole transporting layer 18 that overlap the respective pixel regions to thereby form red (R), green (G) and blue (B) light emitting layers 20.

If needed, a hole blocking layer 21, an electron transporting layer 22, and an electron injecting layer 23 are sequentially formed over the whole surface of substrate 10, and a second electrode layer 24 is formed on electron injecting layer 23. In a typical OLED, hole injecting layer 16, hole transporting layer 18, light emitting layer 20, hole blocking layer 21, electron transporting layer 22, and electron injecting layer 23 are thin films made of an organic compound.

In a typical full-color OLED device, there is generally differences in luminous efficiency between respective pixel regions, i.e., the respective colors. For example, a green light emitting material has a higher luminous efficiency than red

and blue light emitting materials, and a red light emitting material has a higher luminous efficiency than a blue light emitting material.

As a result, much research has been performed to obtain maximum luminous efficiency and luminance by controlling the thickness of organic thin films. For example, Japanese Published Application No. 4-137485 discloses a technique for improving luminous efficiency by forming the electron transporting layer of a thickness between 30 to 60 nm on a structure that an anode, a hole transporting layer, a light emitting layer, an electron transporting layer, and a cathode are sequentially formed.

Japanese Published Application No. 4-328295 discloses a technique of substantially increasing luminance by controlling the thickness of the electron transporting layer such that the light generated from the light emitting layer interferes with the light reflected from the cathode. Also, Japanese Published Application No. 7-240277 discloses an OLED device that controls an optical film thickness to improve luminance, particularly the color purity of blue light.

The OLED devices described above provide different optical film thicknesses for each color to thereby improve luminance. However, it is very difficult to form optical films of different thicknesses by using different manufacturing processes for each color.

SUMMARY OF THE INVENTION

It is an object of the present invention to provide an OLED device that has optimum resonance structures for respective R, G and B pixel regions and a method of fabricating the same.

The present invention discloses an organic electroluminescent display device including: a substrate having first, second, and third pixel regions; a plurality of first electrodes formed on the substrate in each of the first to third pixel regions; a hole injecting layer formed on the substrate to cover the first electrodes; a first hole transporting layer formed on the hole injection layer in the first, second, and third pixel regions; a second hole transporting layer formed on a portion of the first hole transporting layer in the second and third pixel regions; a third hole transporting layer formed on a portion of the second hole transporting layer in the third pixel region; first, second, and third light emitting layers formed on the first, second, and third hole transporting layers, respectively; and a second electrode formed on the first, second, and third light emitting layers, wherein a thickness of the second hole transporting layer is one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the first and second pixel regions, and a thickness of the third hole transporting layer is one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the second and third pixel regions.

The present invention further discloses an organic electroluminescent display device including first, second, and third pixel regions, each pixel region having a lower electrode and an organic light emitting layer. The difference between a distance from the lower electrode to the organic light emitting layer in one pixel region and a distance from the lower electrode to the organic light emitting layer in an adjacent pixel region is one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the adjacent two pixel regions.

The present invention discloses a method for fabricating an organic electroluminescent display device including: preparing a substrate; forming a plurality of first electrodes on the substrate; forming a pixel defining layer on the substrate to cover the first electrodes; patterning the pixel defining layer to expose a light emitting region, thereby defining light emitting regions in each of a first, second, and third pixel region; forming a hole injecting layer on the substrate; forming a first hole transporting layer on the hole injecting layer; forming a second hole transporting layer on the first hole transporting

layer in the second and third pixel regions; forming a third hole transporting layer on the second transporting layer in the third pixel region; patterning first, second, and third light emitting material layers on the respective first, second, and third hole transporting layers to form first, second, and third light emitting layers in the respective first, second, and third pixel regions; and forming a second electrode on the first, second, and third light emitting layers. A thickness of the second hole transporting layer is one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the first and second pixel regions, and a thickness of the third hole transporting layer is one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the second and third pixel regions.

In an alternative method for fabricating an organic electroluminescent display device, the method includes forming the first hole transporting layer and then forming the first light emitting material layer; forming the second hole transporting layer and then forming the second light emitting material layer; and forming the third transporting layer and then forming the third light emitting material layer.

BRIEF DESCRIPTION OF THE DRAWINGS

The features and advantages of the present invention will become more apparent to those of ordinary skill in the art when describing in detail embodiments thereof with reference to the attached drawings.

FIG. 1 is a cross-sectional view illustrating a typical full-color OLED device.

FIG. 2 is a cross-sectional view illustrating an OLED device according to an embodiment of the present invention.

FIG. 3 is a cross-sectional view illustrating an OLED device according to another embodiment of the present invention.

FIG. 4 and FIG. 5 are graphs of an efficiency and a color coordinate of a red color OLED device according to first embodiment of the present invention.

FIG. 6 and FIG. 7 are graphs of an efficiency and a color coordinate of a green color OLED device according to second embodiment of the present invention.

FIG. 8 is a graph of power consumption of a blue color OLED device according to third embodiment of the present invention.

DETAILED DESCRIPTION OF THE INVENTION

The present invention will now be described more fully hereinafter with reference to the accompanying drawings, in which embodiments of the invention are shown. This invention may, however, be embodied in different forms and should not be construed as limited to the embodiments set forth herein. Rather, these embodiments are provided so that this disclosure will be thorough and complete, and will fully convey the scope of the invention to those skilled in the art.

In the drawings, the thickness of layers and regions are exaggerated for clarity. It will be understood that when an element such as a layer, film, region or substrate is referred to as being "on" another element, it can be directly on the other element or intervening elements may also be present. In contrast, when an element is referred to as being "directly on" another element, there are no intervening elements present. Like numbers refer to like elements throughout the specification.

Referring to FIG. 2, the OLED device of the present invention may include: a substrate **210** having a first pixel region **100**, a second pixel region **200**, and a third pixel region **300**; and a plurality of first electrodes **212** formed on portions of the substrate **210** in each of pixel regions **100**, **200**, **300**.

Pixel regions **100**, **200**, **300** implement different colors, which may correspond to red, green, or blue. For example,

assuming that first pixel region **100** is red and second pixel region **200** is green, then third pixel region **300** is blue. Further, assuming that first pixel region **100** is green and second pixel region **200** is blue, then third pixel region **300** is red.

Preferably, first pixel region **100** is blue, the second pixel region **200** is green, and the third pixel region **300** is red. But the invention is not limited to such an arrangement of the pixel regions that comprise a pixel.

A transparent insulating substrate such as a glass substrate or a plastic substrate may be used for substrate **210**.

The plurality of first electrodes **212** may be reflecting electrodes. The reflecting electrode can be made from a group comprising aluminum (Al), aluminum alloy, a dual-layered reflecting anode which contains indium tin oxide (ITO) or indium zinc oxide (IZO) and silver (Ag), and a triple-layered electrode that contains Ag and ITO.

Subsequently, a pixel defining layer **214** is deposited on first electrodes **212**. Pixel defining layer **214** is patterned to include an opening portion corresponding to a light emitting region. Pixel defining layer **214** may be formed of an organic insulating layer such as benzo-cylo-butene (BCB) or acrylic resin.

Then, a hole injecting layer **216** is formed on first electrode layer **212**. Hole injecting layer **216** may be formed over the whole surface of substrate **210** as a common layer to cover the respective pixel regions **100**, **200**, **300**. Hole injecting layer **216** may be made of a typical hole injecting layer material such as copper phthalocyanine (CuPc) or 4,4',4"-tris(N-3-methylphenyl-N-phenylamino)-triphenylamine (mTDATA).

A first hole transporting layer **218-1** is formed over the whole surface of substrate **210** to cover hole injecting layer **216**. First hole transporting layer **218-1** may be formed as a common layer. First hole transporting layer **218-1** may have a thickness between 300-500 Å or the total thickness of both hole injecting layer **216** and first hole transporting layer **218-1** may be between 1,300-1,500 Å.

A second hole transporting layer **218-2** is formed using a fine metal mask on portions of the first hole transporting layer **218-1** overlapping second and third pixel regions **200**, **300**.

A third hole transporting layer **218-3** is formed again using a fine metal mask on a portion of the first hole transporting layer **218-1** overlapping third pixel region **300**. As a result, hole transporting layer **218** is formed having portions of different thicknesses overlapping each of the pixel regions **100**, **200**, **300**.

Red, green, and blue light have different wavelengths at maximum intensity. For example, at maximum intensity, blue light has a wavelength of approximately 460 nm, green light has a wavelength of approximately 520 nm, and red light has a wavelength of approximately 630 nm. At this time, if both an optical path (e.g., "a" in first pixel region **100**) and an optical thickness (e.g., "a/2" in first pixel region **100**) between first electrode **12** and the light emitting layer **20** are identical for the respective colors but there is a difference in a moving distance of light according to the wavelength for each color, optimum optical characteristics cannot be obtained.

Therefore, by providing differing optical thicknesses between a first electrode and a light emitting layer for each color to account for wavelength differences between the respective colors at a maximum intensity, an optimum optical resonance structure can be obtained.

To achieve an optimum optical resonance structure, a difference between optical paths (i.e., optical thicknesses) between first electrodes **212** and light emitting layers **220-1**, **220-2** in the adjacent two pixel regions **100**, **200** is set to one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of the wavelength difference of the colors at maximum intensity for each pixel region. In FIG. 2, the differences in optical paths between pixel regions **100**, **200** is set at one-half ($\frac{1}{2}$) the wavelength difference at maximum intensity

For example, as shown in FIG. 2, assuming that a difference between the wavelengths of the colors at maximum intensity for the first and second pixel regions **100**, **200** is $2x$, then a difference between the optical path from first electrode **212** to light emitting layer **220-1** in first pixel region **100** and an optical path from first electrode **212** to light emitting layer **220-2** in second pixel region **200** is set to $2x$. Thus, if the optical path of the first pixel region **100** is " a ", then the optical path of the second pixel region **200** is set to " $a+2x$." Therefore, a difference between the optical thickness of first pixel region **100** and second pixel region **200** becomes " x " to provide the optical path " $a+2x$ " in second pixel region **200**.

Accordingly, if the thickness second hole transporting layer **218-2** is set to " x ", the optimum optical resonance structure can be obtained. The value of " x " may be between 300-500 Å or the total thickness of both hole injecting layer **216** and the first and second hole transporting layers **218-1**, **218-2** may be between 1,300-1,500 Å.

Further, assuming that a difference between a wavelengths of the colors at maximum intensity for the second and third pixel regions **200**, **300** is $2y$, then a difference between the optical path from first electrode **212** to light emitting layer **220-2** in second pixel region **200** and an optical path from first electrode **212** to light emitting layer **220-3** in third pixel region **300** is $2y$. Thus, if third transporting layer **218-3** is formed at the thickness of " y " to provide the optical path " $a+2x+2y$ " in third pixel region **300**, then the optimum optical resonance structure can be obtained. The value of " y " may be between 300 Å-500 Å or the total thickness of the hole injecting layer **216** and first, second, and third hole transporting layers **218-1**, **218-2**, **218-3** may be between 2,100-2,300 Å.

The embodiment described above illustrated an optical thickness difference of one-half ($\frac{1}{2}$) the wavelength difference of the colors at maximum intensity for adjacent pixel regions, but the OLED device having the optimum resonance structure can be manufactured using a varying thicknesses from approximately one-third ($\frac{1}{3}$) to two thirds ($\frac{2}{3}$) of this wavelength difference.

Second and third hole transporting layers **218-2**, **218-3** can be formed on the respective pixel regions **200**, **300** separately, but to simplify the manufacturing process second transporting layer **218-2** may be formed as a common layer overlapping both second and third pixel regions **200**, **300**.

Here, first, second, and third hole transporting layers **218-1**, **218-2**, **218-3** may be made of N,N'-di(1-naphthyl)-N,N'-diphenyl-benzidine (NPD) or polyethylenedioxythiophene (PEDOT). In addition, each hole transporting layer **218-1**, **218-2**, **218-3** may be made of different materials from one another.

The thickness of first hole transporting layer **218-1** is set to satisfy the device characteristics for the respective pixel regions. Using blue as an example, if hole injecting layer **216** has thickness of 1,000 Å, then the thickness of first hole transporting layer **218-1** may be 300-500 Å. Since the optimum efficiency of blue light is at a wavelength of approximately 460 nm, i.e., 4,600 Å, an optimum efficiency can be obtained, due to constructive interference, when the total thickness of hole injecting layer **216** and hole transporting layer **218-1** is around 1,300 Å, which in consideration of the optical path is closest to one-half the wavelength of blue light.

First, second, and third light emitting material layers may be deposited on hole transporting layer **218** and then patterned to form respective first, second, and third light emitting layers **220-1**, **220-2**, **220-3**. In the described embodiment, first, second, and third pixel regions **100**, **200**, **300** correspond to red, green and blue colors to implement the full-color OLED device. However, if device characteristics such as luminous efficiency are considered, the red pixel region may have the thickest hole transporting layer because red has the longest wavelength, the green pixel may have the next thickest hole transporting layer because green has the next longest

wavelength, and blue subpixel may have the least thick hole transporting layer because blue has the shortest wavelength.

Therefore, for achieving optimal luminous efficiency, a blue light emitting layer **220-1** may be formed in first pixel region **100**, a green light emitting layer **220-2** may be formed in second pixel region **200**, and a red light emitting layer **220-3** may be formed in third pixel region **300**.

The red light emitting layer contains carbazole biphenyl (CBP) or 1,3-dicarbazole-benzene (mCP) as a host material and a phosphorescent material which contains at least one dopant material selected from a group comprised of PQIr (acac)(bis(1-phenylquinoline)-acetylacetonate-iridium), PQIr (tris(1-phenylquinoline) iridium), and PtOEP (platinum-octaethylporphyrin). Also, the red light emitting layer may be made of a fluorescent material such as Eu(DBM)₃ (Phen):PBD or Perylene.

The green light emitting layer contains CBP or mCP as a host material and contains a phosphorescent material which contains Ir(ppy)₃ (fac tris(2-phenylpyridine) iridium) as a dopant material. The green light emitting layer may be made of a fluorescent material such as Alq₃ (aluminum-tris(8-hydroxyquinolino)).

The blue light emitting layer is made of a fluorescent material which may contain one of the following: DPVBi, spiro-DPVBi, spiro-6P, distyrylbenzene (DSB), distyrylarylene (DSA), PFO-based polymer, and PPV-based polymer. The blue light emitting layer can be made from one of the fluorescent materials listed above instead of a phosphorescent material to improve the stability of optical characteristics.

The light emitting layer may be formed using known techniques such as a laser induced thermal imaging (LITI), an ink jet method, a vacuum deposition method, or any other suitable technique for forming such a layer.

Second electrode layer **24** may be formed of a transmissive metal electrode such as Ca, Ca/Ag, or Mg/Ag.

The OLED device of the present invention may further include at least one of the following: hole blocking layer **221**, electron transporting layer **222**, and electron injecting layer **223**.

Hole blocking layer **221** may be made of bis(2-methyl-8-quinolinolate)-(4-hydroxy-biphenyl)-aluminum (BALq); hole transporting layer **22** may be made of polycyclic hydrocarbon-like derivative, heterocyclic compound, or tris(8-quinolitorato)-aluminum (Alq₃); and electron injecting layer **23** may be made of LiF, Liq, NaF or Naq.

Moreover, a passivation layer (not shown) may further be formed on second electrode layer **24**. The passivation layer may be made of SiN_x or SiO₂.

Referring to FIG. 3, the OLED device according to another embodiment of the present invention is arranged in as similar manner as the OLED illustrated in FIG. 2.

Unlike the previous embodiment, however, the hole transporting layers of different thicknesses are formed individually in each pixel region. For example, a first hole transporting layer **318-1** is formed on the portion of hole injecting layer **216** disposed in only first pixel region **100**.

Subsequently, a second hole transporting layer **318-2** is formed only in second pixel region **200**, and thereafter a third hole transporting layer **318-3** is formed only in third pixel region **300**.

In the previous embodiment, the hole transporting layer **218** is formed of overlapping multiple layers **218-1**, **218-2**, **218-3**, but the hole transporting layer of another embodiment of the present invention is formed such that one layer **318-1**, **318-2**, **318-3** is formed in each of the pixel regions **100**, **200**, **300**, respectively.

As in the previous embodiment, the first, second, and third hole transporting layers may be made of different materials from one another.

Also, after depositing the hole transporting layers **318-1**, **318-2**, **318-3**, red, green, and blue light emitting materials

may be deposited using a fine metal mask to form light emitting layers 220-1, 220-2, 220-3. Alternatively, each light emitting layer may be deposited directly after its corresponding hole transporting layer is deposited. For example, a blue light emitting layer 220-1 may be deposited using a fine metal mask directly after depositing first hole transporting layer 318-1, a green light emitting layer 220-2 may be deposited directly after depositing second hole transporting layer 318-2, and then a red light emitting layer 220-3 may be deposited directly after depositing third hole transporting layer 318-3.

The below manufacturing examples are to describe a method for manufacturing an OLED device with red, green and blue light emitting layers according to the present invention.

MANUFACTURING EXAMPLE R1

A reflective pixel electrode is prepared such that a substrate (aluminum and ITO) (available from SDI company) having a thickness of 1,300 Å is cut to have a size of 50 mm×50 mm×0.7 mm, is ultrasonic-cleaned in Isopropyl alcohol and pure water during five minutes respectively and then is ultraviolet and ozone-cleaned during thirty minutes.

A hole injecting layer having a thickness of 1,000 Å is formed on the pixel electrode by using m-TDATA which is a hole injecting material, and a hole transporting layer having a thickness of 1,200 Å is formed on the hole injecting layer using a NPB which is a hole transporting material.

A red light emitting layer having a thickness of 300 Å is formed on the hole transporting layer using CBP and BPTI as a red light emitting material, and a hole blocking layer having a thickness of 50 Å is formed by depositing Balq on the red light emitting layer. Alq3 is deposited at a thickness of 250 Å on the hole blocking layer to form an electron transporting layer, and LiF is deposited at a thickness of 3 Å on the electron transporting layer to form an electron injecting layer. Finally, a transparent opposite electrode is formed at a thickness of 180 Å using MgAg, thereby manufacturing the OLED device. The OLED device manufactured by the manufacturing example R1 is referred to as Sample R1.

MANUFACTURING EXAMPLE R2

A manufacturing method of the manufacturing example R2 is the same as that of the manufacturing example R1 except that the hole transporting layer is formed at a thickness of 1,000 Å. The OLED device manufactured by the manufacturing example R2 is referred to as Sample R2.

MANUFACTURING EXAMPLE R3

A manufacturing method of the manufacturing example R3 is the same as that of the manufacturing example R1 except that the hole transporting layer is formed at a thickness of 1,400 Å. The OLED device manufactured by the manufacturing example R3 is referred to as Sample R3.

MANUFACTURING EXAMPLE R

A manufacturing method of the manufacturing example R is the same as that of the manufacturing example R1 except that the hole transporting layer is formed at a thickness of 800 Å. The OLED device manufactured by the manufacturing example R2 is referred to as Sample R.

MANUFACTURING EXAMPLE G1

A manufacturing method of the manufacturing example G1 is the same as that of the manufacturing example R1 except that NPB as a hole transporting material is deposited at

a thickness 800 Å to form the hole transporting layer and CBP and Irppy as a green light emitting material are deposited at 300 Å to form a green light emitting layer instead of the red light emitting layer. The OLED device manufactured by the manufacturing example G1 is referred to as Sample G1.

MANUFACTURING EXAMPLE G2

A manufacturing method of the manufacturing example G2 is the same as that of the manufacturing example G1 except that the hole transporting layer is formed at a thickness of 600 Å. The OLED device manufactured by the manufacturing example G2 is referred to as Sample G2.

MANUFACTURING EXAMPLE G3

A manufacturing method of the manufacturing example G3 is the same as that of the manufacturing example G1 except that the hole transporting layer is formed at a thickness of 900 Å. The OLED device manufactured by the manufacturing example G3 is referred to as Sample G3.

MANUFACTURING EXAMPLE G

A manufacturing method of the manufacturing example G is the same as that of the manufacturing example G1 except that the hole transporting layer is formed at a thickness of 500 Å. The OLED device manufactured by the manufacturing example G is referred to as Sample G.

MANUFACTURING EXAMPLE B1

A manufacturing method of the manufacturing example B1 is the same as that of the manufacturing example R1 except that NPB as a hole transporting material is deposited at a thickness 400 Å to form the hole transporting layer and IDE140 (available from Idemitsu company) and IDE105 (available from Idemitsu company) as a blue light emitting material is deposited at 150 Å to form a blue light emitting layer instead of the red light emitting layer. The OLED device manufactured by the manufacturing example B1 is referred to as Sample B1.

MANUFACTURING EXAMPLE B2

A manufacturing method of the manufacturing example B2 is the same as that of the manufacturing example B1 except that the hole transporting layer is formed at a thickness of 300 Å. The OLED device manufactured by the manufacturing example B2 is referred to as Sample B2.

MANUFACTURING EXAMPLE B3

A manufacturing method of the manufacturing example B3 is the same as that of the manufacturing example B1 except that the hole transporting layer is formed at a thickness of 500 Å. The OLED device manufactured by the manufacturing example B3 is referred to as Sample B3.

MANUFACTURING EXAMPLE B

A manufacturing method of the manufacturing example B is the same as that of the manufacturing example B1 except that the hole transporting layer is formed at a thickness of 200 Å. The OLED device manufactured by the manufacturing example B is referred to as Sample B.

EVALUATION EXAMPLE 1

Evaluation of Efficiency a Color Coordinate and Power Consumption of Samples Obtained From the Above-Described Manufacturing Examples

Performance of the samples described above has been evaluated. Efficiency and a color coordinate of Samples R1, R2, R3, and R and Samples G1, G2, G3, and G have been evaluated and are shown in FIGS. 4 to 7. Efficiency and color purity have been measured using the IVL measuring device (PhotoResearch PR650, Keithley 238).

Performance of Samples B1, B2, B3, and B has been evaluated by measuring power consumption of respective samples, and the result is shown in FIG. 8. In case of blue color emission, the color coordinate variation sensitively affects the whole power consumption and thus has been evaluated using power consumption measured in consideration of both the coordinate and efficiency. The power consumption has been calculated after evaluating the efficiency and the color purity using the IVL measuring device (PhotoResearch PR650, Keithley 238).

In FIGS. 4 to 8, an x-axis denotes a thickness of the hole transporting layer of respective samples.

FIG. 4 is a graph illustrating efficiencies of Samples R1, R2, R3, and R. As shown in FIG. 7, the efficiency of Sample R does not reach even 1, but the efficiency of Sample R1 is more than 6, and thus it can be understood that Sample R1 has very high efficiency.

FIG. 5 is a graph illustrating color coordinates of Samples R1, R2, R3, and R. Since a NTSC level of the red is (0.67, 0.32), the color coordinate of Sample R is (0.635, 0.36) which does not reach the red NTSC level, but the color coordinate of Sample R1 is (0.672, 0.32), and thus it can be understood that Sample R1 has very excellent color coordinate.

FIG. 6 is a graph illustrating efficiencies of Samples G1, G2, G3, and G.

As shown in FIG. 9, the efficiency of Sample G is just 5, but the efficiency of Sample G1 is about 25 which is five times as high as that of Sample 5, and thus it can be understood that Sample G1 has very high efficiency.

FIG. 7 is a graph illustrating color coordinates of Samples G1, G2, G3, and G. Since a NTSC level of the green is (0.21, 0.71), the color coordinate of Sample G is (0.14, 0.65) which does not reach the red NTSC level, but the color coordinate of Sample G1 is (0.21, 0.726), and thus it can be understood that Sample G1 has very excellent color coordinate.

EMBODIMENT 1

This embodiment describes a method for manufacturing an OLED device which has all of red, green and blue light

emitting layers as an OLED device which is optimized in thickness of the hole injecting layer and the hole transporting layer.

A substrate having a thin film transistor (TFT) is prepared, and a pixel electrode made of aluminum is formed at a thickness 1,000 Å in the form of stripe. Here, the pixel electrode is formed to be electrically connected to source and drain electrodes of the TFT arranged on the lower substrate.

A pixel defining layer which defines regions on which red, green and blue light emitting layers are to be formed is formed on the pixel electrode using a silicon oxide material. Then, m-TDATA as a hole injecting material is deposited at a thickness of 1,000 Å to form the hole injecting layer. NPB as a hole transporting material is deposited at a thickness of 400 Å to form the hole transporting layer. Using a photo mask, NPB is additionally deposited at a thickness of 400 Å on the region on which the green light emitting layer is to be formed, and NPB is additionally deposited at a thickness of 800 Å on the region on which the red light emitting layer is to be formed, so that a thickness of the hole transporting layer corresponding the red light emitting region is 1,200 Å, a thickness of the hole transporting layer corresponding the green light emitting region is 800 Å, and a thickness of the hole transporting layer corresponding the blue light emitting region is 400 Å.

On the hole transporting layer, CBP and BTPPr as a red light emitting material are formed at a thickness of 300 Å, CBP and Irppy as a green light emitting material are formed at a thickness of 300 Å, and IDE140 (available from Idemitsu company) and IDE105 (available from Idemitsu company) as a blue light emitting material are formed at a thickness of 150 Å.

BaIq is deposited on the light emitting layer to form the hole blocking layer of a thickness of 50 Å. Alq3 is formed on the hole blocking layer at a thickness of 250 Å to form the electron transporting layer, and LiF is formed on the electron transporting layer at a thickness of 3 Å. Then, Mg:Ag is formed at a thickness of 180 Å as the transparent opposite electrode, whereby manufacturing the OLED device.

Evaluation 2

Performance Evaluation of the OLED Device of Embodiment 1

Voltage, current, luminance, efficiency, and color coordinate of the OLED device manufactured by Embodiment 1 have been evaluated by the same method of Evaluation Example 1. The result is shown in Table 1.

TABLE 1

	Voltage (V)	Current (mA/cm ²)	luminance (cd/m ²)	Efficiency (cd/A)	x color coordinate	y color coordinate
Red light emitting layer	8.17	37.19	2000	5.39	0.67	0.32
Green light emitting layer	6.56	16.40	4000	24.45	0.21	0.72
Blue light emitting layer	6.36	42.92	600	1.40	0.14	0.06

FIG. 8 is a graph illustrating power consumption of Samples B1, B2, B3, and B. As shown in FIG. 8, Sample B has power consumption of 570 mW which is very high, but Sample B1 has just power consumption of about 400 mW, and thus it can be understood that Sample B1 has very excellent power consumption.

As can be seen Table 1, the OLED device of Embodiment 1 is excellent in luminance, efficiency and color coordinate for respective color light emitting layers.

EMBODIMENT 2

This embodiment describes a method for manufacturing a flat panel display device which has two or more OLED devices to display through both sides.

A transparent substrate which has first and second display regions and a thin film transistor is prepared. A first OLED device is formed on the first display region of the substrate in

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the same way as Embodiment 1. A second OLED device which has layered structure of Table 2 below is formed on a surface corresponding to the surface on which the first OLED device is formed, thereby manufacturing the flat panel display device which can display through both sides. That is, the first 5 OLED device is a front light emitting type which has a reflective pixel electrode and a transparent opposite electrode, whereas the second OLED device is a bottom light emitting type which has a transparent pixel electrode and a reflective opposite electrode.

TABLE 2

	Red light emitting region	Green light emitting region	Blue light emitting region
Pixel electrode	ITO 1500□	ITO 1500□	ITO 1500□
Hole transporting layer	NPB(500□)	NPB(500□)	NPB(500□)
Light emitting layer host	CBP(300□)	CBP(300□)	IDE140(200□)
Light emitting layer dopant	BTPIr(10 weight %)	Ir(ppy) ₃ (5 weight %)	IDE105(5 weight %)
Hole blocking layer	Balq(50□)	Balq(50□)	Balq(50□)
Electron transporting layer	Alq ₃ (200□)	Alq ₃ (200□)	Alq ₃ (200□)
Electron injecting layer	LiF(10□)	LiF(10□)	LiF(10□)
Opposite electrode	Al(3000□)	Al(3000□)	Al(3000□)

EVALUATION EXAMPLE 3

Performance Evaluation of the Flat Panel Display Device of Embodiment 2

Voltage, current, luminance, efficiency, and color coordinate of the first and second OLED devices of the flat panel display device of Embodiment 2 have been evaluated by the same method of Evaluation Example 1. Performance evaluation result of the first OLED device is the same as that of Table 1, and performance evaluation result of the second OLED device is shown in Table 3.

TABLE 3

	Voltage (V)	Current (mA/cm ²)	Luminance (cd/m ²)	Efficiency (cd/A)	x color coordinate	y color coordinate
Red light emitting layer	6.803	12.779	600	4.712	0.677	0.320
Green light emitting layer	6.641	3.516	1000	28.518	0.316	0.619
Blue light emitting layer	6.142	14.020	700	4.986	0.148	0.152

As can be seen in Tables 2 and 3, the flat panel display device which can display through both sides has excellent performance.

As described herein, according to the present invention, the hole transporting layer may have different thicknesses according to the color implemented by each pixel region, and, thus, provides a full-color OLED device with an optimum resonance structure.

What is claimed is:

1. An organic electroluminescent display device, comprising:

a substrate including a first pixel region, a second pixel region, and a third pixel region;

a plurality of first electrodes formed on the substrate in each of the first, second, and third pixel regions;

a hole injecting layer formed on the substrate to cover the plurality of first electrodes;

a first hole transporting layer formed on the hole injecting layer in the first, second, and third pixel regions;

a second hole transporting layer formed on a portion of the first hole transporting layer in the second and third pixel regions;

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a third hole transporting layer formed on a portion of the second hole transporting layer in the third pixel region;

a first light emitting layer formed on the first hole transporting layer;

a second light emitting layer formed on the second hole transporting layer;

a third light emitting layer formed on the third hole transporting layer; and

a second electrode formed on the first, second, and third light emitting layers,

wherein a thickness of the second hole transporting layer is approximately one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the first pixel region and the second pixel region, and the thickness of the third hole transporting layer is approximately one-third ($\frac{1}{3}$) to two-thirds ($\frac{2}{3}$) of an optical wavelength difference between the second pixel region and the third pixel region.

2. The device of claim 1, wherein the thickness of the second hole transporting layer is approximately one-half ($\frac{1}{2}$) of an optical wavelength difference between the first pixel region and the second pixel region, and the thickness of the third hole transporting layer is approximately one-half ($\frac{1}{2}$) of an optical wavelength difference between the second pixel region and the third pixel region.

3. The device of claim 1, wherein each of the first, second, and third pixel regions implement different colors, which correspond to red, green or blue.

4. The device of claim 3, wherein the first pixel region corresponds to blue, the second pixel region corresponds to green, and the third pixel region corresponds to red.

5. The device of claim 4, wherein the first and second pixel regions are adjacent to each other, and the second and third pixel regions are adjacent to each other.

6. The device of claim 1, wherein a thickness of the first hole transporting layer is between approximately 300 Å and 500 Å, and a total of the hole injecting layer and the first hole transporting layer is between approximately 1,300 Å and 1,500 Å.

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7. The device of claim 5, wherein the thickness of the second hole transporting layer is between approximately 300 Å and 500 Å, and a total thickness of the hole injecting layer and the first hole transporting layer, and the second hole transporting layer is between approximately 1,700 Å and 1,900 Å.

8. The device of claim 5, wherein the thickness of the third hole transporting layer is between approximately 300 Å and 500 Å, and a total thickness of the hole injecting layer, the first hole transporting layer, the second hole transporting layer, and the third hole transporting layer is between approximately 2,100 Å and 2,300 Å.

9. The device of claim 1, wherein each of the first, second, and third hole transporting layers are made of different materials from one another.

10. The device of claim 1, wherein two of the first, second, and third hole transporting layers are made of the same material.

11. The device of claim 1, wherein the first, second, and third hole transporting layers are made of the same material.

12. The device of claim 1, wherein the first hole transporting layer is formed as a common layer.

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13. The device of claim 1, wherein at least one of the first electrodes is a reflecting electrode, and the second electrode is a transparent electrode.

14. The device of claim 1, wherein at least one of the first electrodes is a transparent electrode containing a reflecting layer, and the second electrode is a transmissive metal electrode.

15. The device of claim 14, wherein the transmissive metal electrode includes at least one material from the group consisting of Ca, Ca/Ag, and Mg/Ag.

16. The device of claim 1, further comprising:
at least one layer of a hole blocking layer, an electron transporting layer and an electron injecting layer formed on the first, second, and third light emitting layer.

17. The device of claim 1, further comprising:
a passivation layer formed on the second electrode layer.

18. The device of claim 1, wherein the first, second, and third hole transporting layers are each made of a material from the group consisting of N,N'-di(1-naphthyl)-N,N'-diphenyl-benzidine (NPD) and polyethylenethiophene (PEDOT).

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专利名称(译)	有机电致发光显示装置		
公开(公告)号	US7400088	公开(公告)日	2008-07-15
申请号	US11/185850	申请日	2005-07-21
[标]申请(专利权)人(译)	RYU SEOUNG YOON		
申请(专利权)人(译)	RYU SEOUNG-YOON		
当前申请(专利权)人(译)	三星DISPLAY CO. , LTD.		
[标]发明人	RYU SEOUNG YOON		
发明人	RYU, SEOUNG-YOON		
IPC分类号	H05B33/00		
CPC分类号	H01L51/5265 H01L27/3211 H01L2251/558 H01L51/5048 H01L51/5064		
审查员(译)	帕特尔ASHOK		
优先权	1020040057383 2004-07-22 KR		
其他公开文献	US20060017377A1		
外部链接	Espacenet USPTO		

摘要(译)

本发明公开了一种有机电致发光显示装置及其制造方法，包括：第一空穴传输层，形成在第一，第二和第三像素区域中；第二空穴传输层，形成在第二和第三像素区域中的第一空穴传输层的一部分上；第三空穴传输层，形成在第三像素区域中的第二空穴传输层的一部分上。在第一，第二和第三空穴传输层中的每一个上形成发光层。第二空穴传输层的厚度约为第一和第二像素区域之间的光学波长差的三分之一（ $\frac{1}{3}$ ）至三分之二（ $\frac{2}{3}$ ），第三空穴传输层的厚度约为三分之一（ $\frac{1}{3}$ ）至第二和第三像素区域之间的光学波长差的三分之二（ $\frac{2}{3}$ ）。

